



PATENT  
03345-P0017A WWW/GJL

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants	Michael Heuken, <i>et al.</i>
Serial No. 09/873,041	Filing Date: June 1, 2001
Title of Application:	Method And System For Semiconductor Crystal Production With Temperature Management
Confirmation No. 5097	Art Unit: 1765
Examiner	Matthew J. Song

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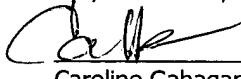
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**Preliminary Amendment in  
Request for Continued Examination Under 37 C.F. R. §1.114**

Applicants herewith present Amendments and Remarks in the Request for Continued Examination in the above U.S. patent application. Please amend the Claims as set forth below.

Mailing Certificate: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *First Class Mail* in an envelope addressed to: Commissioner for Patents and Trademarks; Post Office Box 1450; Alexandria, VA 22313-1450.

October 10, 2003

  
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